Application/Control No. Applicant(s)/Patent Under Reexamination 10/789,913 NAKAMURA, HIROKI Notice of References Cited Examiner Art Unit Page 1 of 1 Chen-Wen Jiang 3744 **U.S. PATENT DOCUMENTS** Document Number Date Name Classification Country Code-Number-Kind Code MM-YYYY * US-2001/0049943 A1 12-2001 Nakamura et al. 62/176.6 Α US-В US-С US-D US-Ε US-F US-G US-Н USı US-J US-Κ

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